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X-ray standing wave enhanced scattering from mesoporous silica thin films

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X-ray standing wave enhanced scattering effects are observed in mesoporous silica thin films (MSTFs) deposited on rough indium tin oxide coated glass substrates in grazing-incidence small-angle x-ray scattering studies. The distorted-wave Born approximation theory along with a rigorous wave function analysis is employed to elucidate the dynamical scattering processes occurring in MSTFs. The data analysis is significantly simplified by expressing the x-ray scattering intensity from MSTFs in two separate functions of the wave vector transfer, where the in-plane correlation between neighboring mesopore channels is decoupled from the out-of-plane interference interaction. Remarkable agreement is achieved between experiment and theory. *Published by AIP Publishing.*
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Mesoporous films have attracted much attention due to their extensive applications in optics, electronics, sensing, and catalysis.^{1–3} Among them, mesoporous silica thin films (MSTFs), stable over a broad range of temperatures and pH values, can provide versatile platforms for many applications, such as catalyst supports and biomedical carriers. MSTFs with mesopore channels (mesochannels) aligned vertically with respect to their surfaces are difficult to fabricate but particularly desirable, because they offer transport channels for electrons, ions, and molecules, which are suited to solar cell, fuel cell, and membrane separation practices.^{4–6} The physical properties of mesoporous films are largely dependent on their mesopore structure and morphology, e.g., size, shape, orientation, and ordering. In general, transmission electron microscopy (TEM), scanning electron microscopy (SEM), atomic force microscopy (AFM), and x-ray scattering and diffraction techniques have been employed to determine the physical parameters of mesoporous films. These characterization techniques have their own merits and drawbacks and are complementary to one another. For thin films, grazing-incidence small-angle x-ray scattering (GISAXS) is a powerful tool for elucidating the structure, morphology, and ordering at nanometer scale and also capable of providing statistical information and probing buried objects.⁷ In addition, x-ray standing waves (XSWs) were generated at glancing angles in organic films deposited on high-density flat substrates and exploited as a sensitive probe to characterize the internal structure of thin films.^{8–15} Besides density and thickness constraints, the two unstated requirements for XSWs are an ultra-smooth substrate (or an x-ray mirror) and a uniform thin film. It is not obvious that an XSW can be formed inside a porous film sitting on a rough substrate. Herein, synchrotron-based GISAXS

and x-ray reflectivity (XRR) techniques are employed to study the structure and dynamical scattering processes of MSTFs containing vertically aligned mesochannels. XSW-enhanced scattering effects are observed from a mesoporous film deposited on a rugged indium tin oxide (ITO) glass substrate. The optical process and the electric field intensity (EFI) distribution in each layer are evaluated through a rigorous wave function analysis, while the multiple scattering effect is accounted by means of the distorted-wave Born approximation (DWBA) theory.

The MSTF samples were prepared via the oil-water biphasic stratification approach. The detailed synthesis procedure will be reported elsewhere. GISAXS and XRR measurements were carried out at the beamlines BL16B and BL14B of Shanghai Synchrotron Radiation Facility (SSRF), respectively, with the incident x-ray photon energy of 10 keV (wavelength $\lambda = 1.24$ Å). Two-dimensional GISAXS patterns were collected using a Mar165 CCD detector with the pixel size of $80\ \mu\text{m} \times 80\ \mu\text{m}$ and the sample-to-detector distance was set at 1860 mm. The experimental setup and scattering geometry are schematically shown in Fig. 1(a). The mesochannels are aligned vertically to the surface of the MSTF that stays conformed to the contour of the ITO substrate as shown by the TEM and SEM images in Fig. 1(b). There are visible crystal grains in the ITO substrate and its surface roughness is about 2.5 nm as shown by the SEM and AFM images in Fig. 1(c). The thickness of MSTF is around 30 nm and that of ITO is about 180 nm.

As is known, the critical angles for total external reflection of silica, ITO, and glass at photon energy of 10 keV are 0.173° , 0.296° , and 0.172° , respectively. Since the critical angle of ITO is larger than that of silica, XSWs could be generated inside the MSTF layer of the MSTF/ITO/glass system.⁸ In order to investigate its x-ray scattering property, a series of GISAXS measurements were conducted by continuously

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FIG. 1. (a) The schematic diagram of the GISAXS geometry. The incident and scattered wave vectors are k_i and k_f , α_i is the incident angle of x-ray beam, $2\theta_f$ and α_f are the azimuthal and exit scattering angles. (b) SEM image of the MSTF/ITO/glass sample. The inset is the cross-sectional TEM image of a free-standing MSTF film. (c) SEM image of the pretreated ITO glass substrate. The AFM image (an area of $1\ \mu\text{m} \times 1\ \mu\text{m}$) is shown in the inset.

varying the incident angle α_i at an increment of 0.02° (supplementary material). The typical scattering patterns taken at α_i of 0.04° , 0.08° , 0.12° , 0.18° , 0.22° , 0.26° , 0.30° , 0.40° , and 0.50° are shown in Figs. 2(a)–2(h), respectively. For $\alpha_i = 0.04^\circ$, well below the critical angle of silica, there are two side lobes with interference fringes and a weak scattering ring R1 passing through them as shown in Fig. 2(a). As α_i increases, the diffuse scattering in the region between two side lobes is intensified and a new scattering ring (R2) appears at large angles as shown in Figs. 2(b) and 2(c). For $\alpha_i = 0.18^\circ$, higher than the critical angle of silica and lower than that of ITO, scattering mainly comes from the MSTF layer. Compared to those in Figs. 2(a)–2(c), the scattering pattern alters notably, where the fringe configuration of the side lobes changes and the intensity modulation along the q_z

FIG. 2. Representative GISAXS patterns taken at incident angles of (a) 0.04° , (b) 0.08° , (c) 0.12° , (d) 0.18° , (e) 0.22° , (f) 0.26° , (g) 0.30° , (h) 0.40° , and (i) 0.50° . R1 and R2 are two scattering rings marked for easy identification. Y1 is the Yoneda peak of ITO.

direction near the beamstop becomes visible. Further increasing the incident angle α_i , as shown in Figs. 2(e) and 2(f), the side lobe profiles are almost faded into the diffuse scattering background, while scattering intensifies in the central region near the beamstop and the intensity modulation along q_z is clearly visible. For $\alpha_i = 0.3^\circ$, at about the critical angle of ITO, x-rays start to penetrate through both the MSTF and ITO layers and enter the glass substrate. At this stage, the diffuse scattering background from the MSTF/ITO interface reduces dramatically, the double-fringe structure of the side lobes is salient, and the scattering ring R2 comes into sight again, as shown in Fig. 2(g). When the incident angle α_i is increased to 0.40° and 0.50° as shown in Figs. 2(h) and 2(i), the scattering feature in the central region, mainly from the ITO film, dominates the whole image and the Yoneda peak of ITO (Y1) emerges above the horizon of the side lobes that are still perceptible from the diffuse scattering background.

The intensity evolution of R2 as a function of the incident angle is one of the salient features on the scattering patterns shown in Fig. 2. To find its physical origin, GISAXS measurements were carried out on ITO-coated glass substrates. The second-order scattering ring owing to crystal grains in ITO films^{16,17} occurs at the same wave vector transfer value as R2 is detected. Close examinations reveal that R2 is centered around the peak positions of the reflected beams. Besides R2, there are multifold x-ray scattering effects encountered in the MSTF/ITO/glass system, including surface-enhanced scattering near the critical angle of total external reflection, XSW-enhanced scattering from the MSTF, and surface roughness and interference scattering effects due to the layered structure. Moreover, the size, shape, and ordering of the MSTF mesochannels bring additional features to the GISAXS patterns. To elucidate the underlying scattering mechanism and trace their physical origins, the transmission, reflection, resonance, and interference interactions for each layer are evaluated through a rigorous wave function analysis by imposing proper boundary conditions at each interface. As shown in the inset of Fig. 3(a), including the top air layer, the ITO glass supported MSTF sample can be divided into four layers with different optical constants, labeled as $j=0, 1, 2$, and 3 for air, MSTF, ITO, and glass, respectively. When x-rays impinge on the MSTF surface, the amplitude of electromagnetic field satisfies the stationary wave equations, and their wave functions can be expressed as

$$\Psi^{(0)}(\mathbf{r}, \mathbf{k}) = e^{ik_{\parallel}r_{\parallel}} \begin{cases} e^{-ik_{z,0}z} + R_0 e^{ik_{z,0}z}, & z > 0 \\ T_1 e^{-ik_{z,1}z} + R_1 e^{ik_{z,1}z}, & 0 \geq z > z_1 \\ T_2 e^{-ik_{z,2}z} + R_2 e^{ik_{z,2}z}, & z_1 \geq z > z_2 \\ T_3 e^{-ik_{z,3}z}, & z_2 \geq z, \end{cases} \quad (1)$$

for an incoming plane x-ray wave with $\mathbf{k} = (k_{\parallel}, k_{z,j})$ and $k_{z,j} = -\sqrt{k_j^2 - k_{\parallel}^2}$. The $k_{z,j}$ are the vertical components of the wave vectors and R_j and T_j are the wave function amplitudes for $j=0, 1, 2$, or 3 . The wave functions describing x-ray propagation in the MSTF/ITO/glass system can be solved through differential equations or a matrix formalism.¹⁸ The resultant expressions for R_j and T_j are given as

FIG. 3. (a) The normalized experimental XRR curve (black circles) and the simulated curve (red line) obtained using the reflectivity coefficient R_0 . (b) The two-dimensional map of the normalized EFI distribution plotted as functions of the x-ray penetration depth and the incident angle α_i , using the parameters obtained from the XRR fitting.

$$\left. \begin{aligned} R_0 &= \eta(r_{0,1} + r_{0,1}r_{1,2}r_{2,3}e^{-2ik_{z,2}h_2} \\ &\quad + r_{1,2}e^{-2ik_{z,1}h_1} + r_{2,3}e^{-2i(k_{z,1}h_1 + k_{z,2}h_2)}) \\ R_1 &= \eta(t_{0,1}r_{1,2}e^{-2ik_{z,1}h_1} \\ &\quad + t_{0,1}r_{2,3}e^{-2i(k_{z,1}h_1 + k_{z,2}h_2)}) \\ T_1 &= \eta(t_{0,1} + t_{0,1}r_{1,2}r_{2,3}e^{-2ik_{z,2}h_2}) \\ R_2 &= \eta t_{0,1}t_{1,2}t_{2,3}e^{-i(k_{z,1}h_1 + 2k_{z,2}h_2)} \\ T_2 &= \eta t_{0,1}t_{1,2}e^{-ik_{z,1}h_1} \\ T_3 &= \eta t_{0,1}t_{1,2}t_{2,3}e^{-i(k_{z,1}h_1 + k_{z,2}h_2)} \end{aligned} \right\}, \quad (2)$$

where $\eta = 1/[1 + r_{0,1}r_{1,2}e^{-2ik_{z,1}h_1} + r_{0,1}r_{2,3}e^{-2i(k_{z,1}h_1 + k_{z,2}h_2)} + r_{1,2}r_{2,3}e^{-2ik_{z,2}h_2}]$. The $r_{j,j+1}$ and $t_{j,j+1}$ are the Fresnel reflection and transmission coefficients for the interface between the j th and $(j+1)$ th layers, whose expressions are given as $r_{j,j+1} = \frac{k_{z,j} - k_{z,j+1}}{k_{z,j} + k_{z,j+1}} e^{-2k_{z,j}k_{z,j+1}\sigma_{j+1}^2}$ and $t_{j,j+1} = 2k_{z,j}/(k_{z,j} + k_{z,j+1})$, where σ_{j+1} is the surface roughness of the $(j+1)$ th layer. The thicknesses of the MSTF and ITO layers are $h_1 = z_0 - z_1$ and $h_2 = z_1 - z_2$, respectively. In this case, R_0 is the reflectivity coefficient of the sample. As shown in Fig. 3(a), the experimental XRR data are given along with the numerical simulation obtained using the expression for R_0 in Eq. (2). The data were fitted through the covariance matrix adaptation evolution strategy (CMA-ES) method.^{19,20} Since the wave functions, whose modulus describe EFI, are continuous

at all the interfaces, the normalized EFI distribution can be simulated for the MSTF/ITO/glass system using the parameters obtained from the XRR fitting, as shown in Fig. 3(b). When the incident angle is less than the critical angle of silica, there are few x-rays that penetrate into the sample. The EFI is greatly enhanced in the MSTF layer when the incident angle is set between the critical angles of silica and ITO. When the incident angle is larger than the critical angle of ITO, the penetration depth of x-rays is strongly increased. As the incident angle increases, the scattering signal from ITO intensifies because x-ray beam reaches deeper and excites more film volume. This is clearly manifested in Figs. 2(h) and 2(i), where the scattering from ITO dominates the central region of the GISAXS patterns and the Yoneda peaks of ITO (Y1) become evident. The first resonance mode (TE_0) of XSWs in the MSTF (the normalized EFI is ~ 10) emerges at the incident angle of 0.18° . This resonance mode presents as a dip on the XRR curve due to the increased absorption in the MSTF film, while the large interface roughness makes the dip shallower. The significance of the TE_0 mode is further demonstrated by the GISAXS pattern shown in Fig. 2(d), where the diffuse scattering from the sample interfaces is substantially suppressed while the scattering signal from the MSTF film is strongly enhanced.

On the basis of the wave function analysis, the DWBA theory^{21–24} is further employed to account for the multiple scattering effect and scattering from the mesochannels of MSTF. The scattering amplitude given as a function of the wave vector transfer $\mathbf{q}$ in this method²⁵ is

$$A(\mathbf{q}) = T_{1,i}T_{1,f}F(q_{\parallel}, q_{1,z}) + T_{1,i}R_{1,f}F(q_{\parallel}, q_{2,z}) \\ + R_{1,i}T_{1,f}F(q_{\parallel}, q_{3,z}) + R_{1,i}R_{1,f}F(q_{\parallel}, q_{4,z}), \quad (3)$$

where T_1 and R_1 are the amplitudes of the reflected and transmitted x-ray beams in the MSTF, whose expressions are given in Eq. (2). The components of wave vector transfers are $q_{\parallel} = \sqrt{q_x^2 + q_y^2}$, $q_{1,z} = k_{z,f} - k_{z,i}$, $q_{2,z} = -k_{z,f} - k_{z,i}$, $q_{3,z} = k_{z,f} + k_{z,i}$, and $q_{4,z} = -k_{z,f} + k_{z,i}$, where $k_{z,i}$ and $k_{z,f}$ are the z components of the wave vectors of the incoming and outgoing x-ray beams given as $k_{z,i} = k_0\sqrt{n^2 - \cos^2 \alpha_i}$ and $k_{z,f} = k_0\sqrt{n^2 - \cos^2 \alpha_f}$, respectively. In these equations, $k_0 = 2\pi/\lambda$, λ is the x-ray wavelength, n is the refractive index, α_i is the incident angle, and α_f is the out-of-plane exit angle of the outgoing x-ray beam as shown in Fig. 1(a). The function F is the form factor of the cylindrical mesochannels

$$F(q_{\parallel}, q_z, R, H) = \left[2\pi R^2 \frac{J_1(q_{\parallel}R)}{q_{\parallel}R} \right] \times \left[H \text{sinc}\left(q_z \frac{H}{2}\right) e^{-iq_z \frac{H}{2}} \right] \\ = F_{\parallel}(q_{\parallel}) \times F_z(q_z), \quad (4)$$

where R and H are the radius and height of the mesochannels. It can be separated into two independent functions of the in-plane ($q_{\parallel}$) and out-of-plane (q_z) components of the wave vector transfer, denoted as $F_{\parallel}$ and F_z . Since there is no long-range ordering of the mesochannels in MSTF, the in-plane structure factor $S(q_{\parallel})$ can be simulated by the paracrystal model up to the second-order approximation²⁶

$$S(q_{\parallel}) = \frac{1}{N} \frac{1 - \Phi(q_{\parallel})^2}{1 - 2\Phi(q_{\parallel})\cos q_{\parallel}D + \Phi(q_{\parallel})^2} - \frac{1}{N^2} \frac{2\Phi(q_{\parallel})[\cos(q_{\parallel}D) - 2\Phi(q_{\parallel}) + \Phi(q_{\parallel})^2 \cos(q_{\parallel}D)]}{[1 - 2\Phi(q_{\parallel})^2 \cos(q_{\parallel}D) + \Phi(q_{\parallel})^2]^2}, \quad (5)$$

where $\Phi(q_{\parallel}) = \exp(-q_{\parallel}^2 \delta_D^2)$, D is the average separation distance between the neighboring mesochannels with a dispersion width δ_D , and N is the number of mesochannels in the coherent scattering region. From Eqs. (3)–(5), we find that the expression for x-ray scattering intensity can also be separated into two independent functions of $q_{\parallel}$ and q_z , as given below

$$I_{\text{GISAXS}}(q_{\parallel}, q_z) = \left[|F_{\parallel}(q_{\parallel})|^2 S(q_{\parallel}) \right] \times |T_{1,i} T_{1,f} F_z(q_{1,z}) + T_{1,i} R_{1,f} F_z(q_{2,z}) + R_{1,i} T_{1,f} F_z(q_{3,z}) + R_{1,i} R_{1,f} F_z(q_{4,z})|^2. \quad (6)$$

In this way, the XSW-enhanced scattering effect that modulates the EFI distribution in MSTF couples only to the q_z component of the form factor, and the correlation between

FIG. 4. (a) The simulated q_y -dependence of the GISAXS pattern. Inset: The experimental (black circles) and theoretical (red line) scattering intensity profiles extracted along the q_y direction at $q_z = 0.13 \text{ nm}^{-1}$. (b) The simulated q_z -dependence of the GISAXS pattern. Inset: The experimental (black circles) and theoretical (red line) scattering intensity profiles extracted along the q_z direction at $q_y = 0.1 \text{ nm}^{-1}$. (c) The experimental GISAXS pattern recorded at $\alpha_i = 0.18^\circ$. (d) The simulated GISAXS pattern obtained by multiplying the data in (a) and (b).

TABLE I. The radius, R , and the height, H , and their standard deviations, σ_R and σ_H , of the mesochannels; the average separation distance, D , and its dispersion width, δ_D , of the neighboring mesochannels; and the number of mesochannels in the coherent scattering region, N (all the units are in nm except N).

R	σ_R	H	σ_H	D	δ_D	N
2.21	0.32	29	0.7	5.35	0.23	14

neighboring mesochannels only affects the in-plane scattering intensity. Applying these results, the GISAXS data analysis becomes clear and tractable, in which the experimental data can be fitted separately in terms of $q_{\parallel}$ and q_z . As shown in Fig. 4(a), the q_y -dependence of the GISAXS pattern is simulated using the in-plane component of Eq. (6), and the inset shows the scattering profile and the theoretical fitting along the q_y direction for $q_z = 0.13 \text{ nm}^{-1}$. In the same way, the q_z -dependence of the scattering pattern calculated using the out-of-plane component of Eq. (6) is shown in Fig. 4(b), where the inset is the experimental and theoretical curves along the q_z direction extracted at $q_y = 0.1 \text{ nm}^{-1}$. Figure 4(c) shows the GISAXS pattern recorded at $\alpha_i = 0.18^\circ$, and Fig. 4(d) is the corresponding simulation result, which is the product of the data in Figs. 4(a) and 4(b), according to Eq. (6). As the EFI is distributed mainly at the center of the MSTF film, the diffuse scattering from the interface roughness is relatively weak and negligible. The structural parameters of MSTF obtained from the GISAXS data fitting are listed in Table I, where σ_R and σ_H are the standard deviations for R and H . They agree well with those obtained from the SEM and TEM measurements. As can be seen by comparing the experimental and theoretical results in Figs. 4(c) and 4(d), the main scattering features are well replicated in the simulation employing the DWBA theory.

In conclusion, MSTFs are synthesized with their mesochannels aligned vertically to ITO glass substrates. X-ray scattering effects of the MSTF/ITO/glass system are comprehensively investigated by GISAXS and XRR techniques. XSWs are generated inside MSTFs even though the film void size and substrate roughness are several orders of magnitude larger than the incident x-ray wavelength. Good agreement is achieved between the experimental and theoretical GISAXS patterns and a complete picture of the dynamical scattering processes occurring in MSTFs is unveiled. The marked features of XSWs found in MSTFs would prompt new applications exploiting their unique properties beyond model films laid on ideal substrates. In view that x-ray scattering from mesochannels is significantly enhanced by XSWs, the present findings should shed light on probing the requisite ionic and molecular transportation activities in mesoporous films engaged in fuel cell, battery and membrane separation applications.

See [supplementary material](#) for the GISAXS pattern of the MSTF film deposited on a bare glass substrate, the XRR fitting parameters, and the estimation of the critical angle of the MSTF film.

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